



PATENT APPLICATION

*IPW AF*

**CERTIFICATE OF MAILING/FACSIMILE TRANSMISSION (37 CFR 1.8)**

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Maria T. Sanchez  
(Print Name)

Date: November 14, 2005

*Maria T. Sanchez*  
(Signature)

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Attorney's Docket No. 2003US301CIP

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application for

Ralph R. DAMMEL et al.

Serial No.: 10/658,840

Group Art Unit: 1752

Filed: September 9, 2003

Examiner: John S Y Chu

For: **Photoresist Composition for Deep Ultraviolet Lithography**

**AMENDMENT AFTER FINAL**

November 14, 2005

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Serial No.: 10/658,840  
Filing Date: September 9, 2003

Dear Examiner:

This is in response to the official action mailed September 13, 2005. Please cancel claim 7. Claim 2 has been amended. A new claim 18 has been added. No new matter has been added. The response contains a complete set of claims and a remarks section.

The response also contains an Information Disclosure Statement and the associated fee.